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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: CEM BASCERI ET AL.

APPLICATION No.: 10/665,099

FILED: SEPTEMBER 17, 2003

FOR: **MICROFEATURE WORKPIECE
PROCESSING APPARATUS AND
METHODS FOR CONTROLLING
DEPOSITION OF MATERIALS ON
MICROFEATURE WORKPIECES**

EXAMINER: WILLIAM M.
BREWSTER

ART UNIT: 2823

CONF. NO: 6145

Amendment Under 37 C.F.R. § 1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Examiner's Amendment appearing in the Notice of Allowance mailed September 30, 2005 in the above-identified application. Please amend the application as follows:

Amendments to the Specification begin on page 2.